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ABSTRACT

Semimetallic iridate compound SrIrO₃ epitaxial films have been deposited by off-axis sputtering, exhibiting excellent crystalline quality as well as smooth surfaces. By performing second-harmonic Hall measurements on a series of SrIrO₃/Co_{1-x}Tb_x bilayers, we quantitatively determined the spin-to-charge interconversion efficiency θ_{SH} of SrIrO₃ and discovered a systematic temperature and film thickness dependent evolution behavior. Notably, the measured $|\theta_{SH}|$ reaches a remarkably large number of ~1.1 at room temperature, which is significantly larger than the value of 5*d* transition metals and comparable to the values reported in some topological material systems. Our findings are further corroborated by ferromagnetic resonance-driven spin pumping studies in SrIrO₃/Py bilayers, highlighting the significant opportunities offered by the iridate compounds in designing next-generation energy-efficient multifunctional spin Hall devices.

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Spin-orbit coupling (SOC) plays a central role in modern spintronic research¹⁻⁷ and for the formation of many exotic quantum phases recently discovered in condensed matter physics such as topological insulators,⁸ Weyl semimetals,⁹ and quantum spin Hall insulators.¹⁰ The iridate compounds, a group of 5*d* transition metal oxides, are naturally relevant to this context due to the heavy element iridium (atomic number z = 77), which tends to exhibit large SOC.¹¹⁻¹⁴ Additionally, the intrinsic sensitivities of complex oxide thin films to the oxygen deficiency, epitaxial strain, film thickness, and stoichiometry provide multiple tuning knobs to efficiently control the electronic and magnetic properties and the associated SOC,^{15–19} promising to bring in desirable functionality for the design of next-generation spintronic devices. To realize these potential benefits, single crystalline oxide thin films with delicately controlled material properties are needed, which require cuttingedge deposition techniques that involve fine tuning of oxygen content, layer-by-layer growth scheme, and accurate control of the epitaxial strain and relaxation. In this work, we have achieved the growth of ferrimagnetic Co_xTb_{1-x} alloy thin films with perpendicular magnetic anisotropy (PMA) onto single crystalline SrIrO3 epitaxial films. With the bilayer structure, we determine the

spin-to-charge interconversion ratio, the figure of merit for spintronic application, of SrIrO₃ to be as large as 1.1. The demonstrated large spin-to-charge interconversion efficiency points to the possibility of achieving devices with ultralow power consumption for magnetic memory and spin logic by incorporating complex oxides into the material landscape of spintronic research.

We first discuss the structural and interfacial condition of the prepared SrIrO₃ thin films. Epitaxial SrIrO₃ films are deposited on (001)-oriented SrTiO₃ substrates using the off-axis sputtering technique.^{15,16} The crystalline quality of the SrIrO₃ films is determined by high-resolution X-ray diffraction (XRD). A representative θ -2 θ scan with 2 θ between 15° and 55° is shown in Fig. 1(a), which indicates the phase-pure epitaxial growth of a 30-nm thick SrIrO₃ film. A zoom-in view of the (002) peak in the inset exhibits pronounced Laue oscillations, reflecting a smooth surface and sharp SrIrO₃/SrTiO₃ interface. We find an out-of-plane lattice constant of the SrIrO₃ film, c = 4.053 Å, larger than the bulk value of 3.942 Å, suggesting a compressive strain induced by the SrTiO₃ substrate. Figure 1(b) shows the X-ray reflectometry (XRR) spectrum of a 30-nm thick SrIrO₃, exhibiting a clear oscillation period from which the film thickness can be accurately determined. The atomic force microscopy (AFM) image of



FIG. 1. (a) Wide angle semilog θ - 2θ XRD scan of a 30-nm thick SrlrO₃ film grown on a SrTiO₃ (001) substrate. Inset: zoom-in view of the (002) peak exhibits pronounced Laue oscillations. (b) XRR scan of a SrlrO₃ film shows a clear oscillation period, corresponding to the film thickness. (c) AFM image of a SrlrO₃ film with a rms roughness of 0.2 nm.

the same sample shown in Fig. 1(c) gives a root mean square (rms) roughness of ~ 0.2 nm.

The first experimental approach that we employ to calibrate the spin-to-charge conversion of epitaxial SrIrO3 thin films is the secondharmonic Hall measurement.²⁰⁻²⁴ This method has been widely used in a variety of magnetic heterostructures consisting of heavy metals and perpendicularly magnetized ferromagnets. Here, we choose ferrimagnetic $Co_{1-x}Tb_x$ (CoTb) alloy with strong PMA²⁵⁻²⁹ as the magnetic electrode and deposit 6.6-nm thick Co1-xTbx onto a series of SrIrO3 thin films with different thicknesses. The deposition of the $Co_{1-x}Tb_x$ film is followed by a 3-nm thick SiN_x capping layer to prevent oxidization of this magnetic layer. A vibrating-sample magnetometry (VSM) measurement is carried out on the samples with the field applied along the out-of-plane direction. The result shown in Fig. 2(a) clearly demonstrates the PMA of the Co1-xTbx film on SrIrO3. In our experiment, $Co_{1-x}Tb_x$ (CoTb) with different chemical compositions is tested. We conclude that a Tb atomic ratio of x = 0.23 is optimal for achieving a square magnetic hysteresis loop. In order to perform harmonic Hall measurements, the continuous thin films are patterned into micrometer-sized Hall bar structures by standard photolithography and dry etching processes with a channel width of $10 \,\mu m$ [Fig. 2(b)]. Figure 2(c) shows the measured anomalous Hall resistance $R_{\rm H}$ of a fabricated device as a function of out-of-plane magnetic field H_{r} . The measured hysteresis loop follows a similar behavior of the VSM results and the coercivity is determined to be \sim 800 Oe. The resistivities of the SrIrO₃ and CoTb films are separately determined to be $1.2 \times 10^{-5} \Omega$ m and $1.0 \times 10^{-5} \Omega$ m, respectively. We note that the resistivity of SrIrO₃ exhibits a weak dependence on the thin film thickness in the regime that we studied. A parallel circuit model is used in the analysis of current distribution in the rest of the discussions.



FIG. 2. (a) Room temperature out-of-plane magnetic hysteresis loop of a SrIrO₃(10 nm)/CoTb(6.6 nm) sample measured by vibrating sample magnetometry. (b) Image of a patterned SrIrO₃(10 nm)/CoTb(6.6 nm) Hall bar device with a channel width of 10 μ m. (c) The measured anomalous Hall resistance $R_{\rm H}$ of a SrIrO₃(10 nm)/CoTb(6.6 nm) Hall bar device as a function of out-of-plane magnetic field H_z . (d) Schematic of a Hall bar device with an illustration of the performed harmonic Hall measurement scheme. The AC current is applied along the *x*-axis and the anomalous Hall voltage is detected along the *y*-axis.

We use the experimental geometry shown in Fig. 2(d) for quantifying the spin Hall effect in SrIrO₃. When an electric charge current J_c flows through the SrIrO₃ layer along the *x*-axis, a spin current will be generated along the *z*-axis with spin polarization σ oriented along the y-axis by the spin Hall effect. The accumulated spin current J_s is injected into the CoTb magnetic free layer, inducing a dampinglike torque $\tau_{\rm DL} \sim \boldsymbol{m} \times (\boldsymbol{\sigma} \times \boldsymbol{m})$ and a fieldlike torque $\tau_{\rm FL} \sim \boldsymbol{\sigma} \times \boldsymbol{m}^3$ where m denotes the magnetization of the CoTb layer. When the magnetic moment reaches an equilibrium position, the effects of these two torques can also be described equivalently through the generated longitudinal $\Delta H_{\rm L} \sim m \times \sigma$ and transverse effective fields $\Delta H_{\rm T} \sim \sigma$, respectively. When an alternating current (AC) is applied through the device channel, the generated $\Delta H_{\rm L(T)}$ causes an oscillation of the CoTb magnetization m around the equilibrium position. By sweeping an inplane external field parallel (H_L , along the $\pm x$ -axis) and transverse ($H_{\rm T}$, along the $\pm y$ -axis) to the current flow direction, we can measure the field dependence of the first-harmonic signal V_{ω} and the out-ofphased (90° off) second-harmonic signal $V_{2\omega}$, from which $\Delta H_{L(T)}$ can be extracted using²

$$\Delta H_{\rm L(T)} = -2 \frac{dV_{2\omega}/dH_{\rm L(T)}}{d^2 V_{\omega}/dH_{\rm L(T)}^2}.$$
 (1)

Figures 3(a) and 3(b) show the in-plane field (H_L) dependence of the measured first-harmonic (V_{ω}) and second-harmonic ($V_{2\omega}$) signals, respectively, of a SrIrO₃(10 nm)/CoTb(6.6 nm) Hall device. It is noted that V_{ω} exhibits a characteristic parabolic behavior with opposite polarities for magnetization pointing along + z and -z directions,



FIG. 3. In-plane longitudinal field $H_{\rm L}$ dependence of the measured (a) first-harmonic Hall signal V_{co} and (b) second-harmonic Hall signal V_{2co} of a SrlrO₃(10 nm)/CoTb(6.6 nm) Hall device. (c) The measured effective field $\Delta H_{\rm L}$ along the longitudinal direction as a function of the applied electrical current density J_c flowing through the SrlrO₃ layer. (d) In-plane transverse field $H_{\rm T}$ dependence of the measured second-harmonic Hall signal V_{2co} . Blue and red curves represent signals when the magnetization points along the +z and -z directions, respectively. (e) SrlrO₃ film thickness $t_{\rm SIO}$ dependence of the obtained $\theta_{\rm SH}$. The blue dashed line indicates the obtained $\theta_{\rm SH}$ for Pt through the same harmonic Hall measurements in a Pt/CoTb control sample. (f) Temperature dependence of $\delta_{\rm SH}$ measured in the SrlrO₃(30 nm)/CoTb(6.6 nm) Hall device in the range of 50–300 K. Inset: temperature dependent resistivity ρ of a 10-nm SrlrO₃ thin film.

while $V_{2\omega}$ follows a linear dependence on $H_{\rm L}$ and the slopes are the same for both magnetic states, which are consistent with the origin of the spin Hall effect induced dampinglike torque.^{21,29} Using Eq. (1), we calculate $\Delta H_{\rm L}$ under different $J_{\rm c}$ and summarize the results in Fig. 3(c). Remarkably, a robust $\Delta H_{\rm L} \sim 4$ Oe was generated at a fairly low electrical current density down to 1.3×10^9 Å/m², suggesting an extraordinarily large SOC of the epitaxial SrIrO₃ film. We note that $\Delta H_{\rm L}$ linearly increases with the magnitude of J_c and switches the sign when *m* flips from the +z to -z direction. Here, we can exclude the contribution from the planar Hall effect and anomalous Nernst effect due to the relatively small field range compared with the strong PMA of the CoTb thin film.²⁰ With equation $\theta_{\rm SH} = \frac{2e\mu_0 M_A \Delta H_1 t_{\rm CoTb}}{I_c \hbar}$, ³¹ $|\theta_{\rm SH}|$ is determined to be 1.08 ± 0.11, significantly larger than the value of 0.22 ± 0.02 of the Pt layer measured in a Pt/CoTb control sample. Here, *e* is the electron charge, μ_0 is the vacuum permeability, \hbar is the reduced Planck's constant, M_s is the saturated magnetization, and t_{CoTb} is the thickness of the CoTb layer. It is noted that the measured

 $V_{2\omega}$ of the same device exhibits little dependence on $H_{\rm T}$ as shown in Fig. 3(d), indicating a negligible contribution from the fieldlike torque generated by the spin Hall effect of the SrIrO₃ layer.

For complex oxide thin films, it is known that the exhibited properties are intrinsically sensitive to strain-induced structural distortions, which is strongly correlated with the film thickness. To explore this possibility, we systematically varied the film thickness of SrIrO₃ from 2 to 30 nm to reveal the evolution of $\theta_{\rm SH}$. As shown in Fig. 3(e), the obtained $|\theta_{\rm SH}|$ remains mostly constant around 0.8–1.2 in the whole thickness range. A possible explanation on the absence of thickness dependence is that the measured spin-orbit torque efficiency heavily depends on the SrIrO₃/CoTb interface, which exhibits a reduced sensitivity to the substrate-induced epitaxial strain and lattice distortions. Here, we do not observe the crystallographic-oriented dependence of the spin Hall angle as reported in Ref. 14. Besides the thickness dependence, we also carried out experiments to measure $|\theta_{\rm SH}|$ at different temperatures. The results for a 30-nm thick SrIrO₃ sample are shown in Fig. 3(f) with temperature varying between 50 K and 300 K. Across the temperature range, the value of $|\theta_{\rm SH}|$ shows an increase from 0.44 ± 0.06 to 1.04 ± 0.15 and the saturation magnetization $M_{\rm s}$ exhibits a weak temperature dependence. Here, we note that the increase in the spin Hall conductivity with temperature indicates that the intrinsic effect cannot be the dominant mechanism.³² A thorough understanding of this origin and the characteristic temperature dependence requires further systematic study which is beyond the scope of this manuscript.

The large spin-orbit torque measured in SrIrO₃ thin films suggests very efficient spin-to-charge interconversion, providing a promising material platform for energy-favorable spin generation and detection. Here, we utilized ferromagnetic resonance (FMR)-driven spin pumping,^{33–36} a widely used experimental tool for detecting spin injections, as an alternative method to qualitatively calibrate $\theta_{\rm SH}$ of SrIrO3 films. Our spin pumping measurements were performed using a coplanar waveguide at room temperature on SrIrO₃/Py bilayers with an approximate sample dimension of 1 mm × 4 mm. During the measurements, a DC magnetic field H is applied along the x-axis and the generated spin pumping voltage $V_{\rm SP}$ is measured across the ${\sim}4$ -mmlong sample along the y-axis as illustrated in Fig. 4(a). At the FMR condition, the Py magnetization M precesses around the equilibrium position and transfers angular momentum to the conduction electrons in the neighboring SrIrO₃ layer through the interfacial exchange coupling,³⁷ resulting in pure spin current J_s along the z-axis with spin polarization σ parallel to *M*. The injected spin current is converted to a charge current, $J_{\rm c} \propto \theta_{\rm SH} J_{\rm s} \times \sigma$, by the inverse spin Hall effect (ISHE).

The field dependent spin pumping signal from a SrIrO₃(10 nm)/ Py(20 nm) sample is shown in Fig. 4(b) at frequency f = 5.5 GHz with microwave power $P_{\rm rf} = 90$ mW at the sample location. The observed $V_{\rm SP}$ changes its sign when the external field *H* reverses the polarity, in consistent with the ISHE mechanism.³³ To compare the efficiency of spin-to-charge conversion in the SrIrO₃ sample with other wellstudied materials, we employed a bilayer film of Pt(5 nm)/Py(20 nm) as a control sample. Notably, the measured $V_{\rm SP}$ of the SrIrO₃/Py sample exhibits an opposite sign compared with the signal of the Pt/Py bilayer, indicating a negative $\theta_{\rm SH}$ of SrIrO₃, in agreement with our harmonic Hall measurement results. The observed spin pumping spectra are dominated by a symmetric Lorenz shape, suggesting a negligible



FIG. 4. (a) Schematic diagram of the ISHE voltage measurement setup. (b) $V_{\rm SP}$ vs H spectra of SrIrO₃(10 nm)/Py(20 nm) and Pt(5 nm)/Py(20 nm) bilayers at f = 5.5 GHz and input microwave power $P_{\rm rf}$ = 90 mW. The curves are offset for clarity. (c) The $V_{\rm SP}$ vs H spectra of SrIrO₃(10 nm)/Py(20 nm) at $P_{\rm rf}$ of 16, 28, 50, and 90 mW (green, purple, blue, and red curves, respectively). Inset: $P_{\rm rf}$ dependence of the corresponding $V_{\rm SP}$ (d) Microwave frequency dependencies of FMR linewidth $\Delta H_{\rm FMR}$ of a bare Py(20 nm) film, Pt(5 nm)/Py(20 nm), and SrIrO₃(10 nm)/Py(20 nm) samples.

contribution from anisotropic magnetoresistance associated with the metallic Py layer.^{35,38} For the SrIrO₃(10 nm)/Py(20 nm) bilayer, the magnitude of $V_{\rm SP}$ reaches 82 μ V, significantly larger than the 37.5 μ V signal observed in the Pt(5 nm)/Py(20 nm) sample. Figure 4(c) shows the spin pumping spectra of the SrIrO₃(10 nm)/Py(20 nm) sample at different $P_{\rm rf}$ of 16, 28, 50, and 90 mW and $f = 5.5 \,\rm{GHz}$. The inset shows the $P_{\rm rf}$ dependence of $V_{\rm SP}$, demonstrating a linear microwave power dependence. Next, we perform frequency dependent FMR measurements on bare Py(20 nm), Pt(5 nm)/Py(20 nm), and SrIrO₃(10 nm)/Py(20 nm) samples to determine the FMR linewidth $\Delta H_{\rm FMR}$ and the interfacial spin mixing conductance $g_{\uparrow\downarrow}$. In all cases, the measured $\Delta H_{\rm FMR}$ follows a linear dependence on microwave frequency f as shown in Fig. 4(d). The obtained $g_{\uparrow\downarrow}$ at Pt/Py and SrIrO₃/ Py interfaces are $(3.8 \pm 0.4) \times 10^{19} \text{ m}^{-2}$ and $(1.1 \pm 0.1) \times 10^{19} \text{ m}^{-2}$, respectively. A reduced spin transfer efficiency at the SrIrO₃/Py interface in comparison with that from the Pt/Py interface could result from a reduced interfacial spin channel density in SrIrO₃/Py because of the much lower density of state in SrIrO₃ than Pt.

Finally, we provide a brief estimation on $\theta_{\rm SH}$ of SrIrO₃ thin films based on the spin pumping results shown above. Due to the uncertainties involved in an accurate determination of local microwave field $h_{\rm rf}$ generated by the coplanar waveguide, here, we focus on obtaining a relative ratio between the spin Hall angle of SrIrO₃ ($\theta_{\rm SIO}$) and Pt ($\theta_{\rm Pt}$). In the spin pumping study, $\theta_{\rm SH}$ could be determined by the following equation:^{35,39}

$$\theta_{\rm SH} = \frac{V_{\rm SP}}{-wR\lambda_{\rm SD} \tanh\left(\frac{t_{\rm NM}}{2\lambda_{\rm SD}}\right) J_{\rm s}},\tag{2}$$

where *w* is the sample width, *R* is the resistance of the bilayer sample, $t_{\rm NM}$ and $\lambda_{\rm SD}$ correspond to the film thickness and spin diffusion length of the spin detector, respectively. $J_{\rm s}$ denotes the magnitude of the spin current at the Py/spin-detector interface, which can be determined using spin mixing conductance $g_{\uparrow\downarrow}$, FMR linewidth $\Delta H_{\rm FMR}$, and $h_{\rm rf}$ with the relationship: $J_{\rm s} \propto g_{\uparrow\downarrow} (\frac{h_{\rm rf}}{\Delta H_{\rm FMR}})^{2.35,39}$ Based on the thickness dependent evolution of $\theta_{\rm SIO}$, the upper limit of $\lambda_{\rm SD}$ of SrIrO₃ is estimated to be ~2 nm, in agreement with the experimentally reported value.¹⁴ Here, we assume a similar $\lambda_{\rm SD}$ of Pt and SrIrO₃ with a magnitude much smaller than that of $t_{\rm NM}$, ^{14,40} yielding an insensitive term of $\tanh\left(\frac{f_{\rm NM}}{2\lambda_{\rm SD}}\right)$ in Eq. (2). By substituting those measured material parameters into the above equation, $|\theta_{\rm SIO}|/|\theta_{\rm Pt}|$ is estimated to be ~3.5, qualitatively in agreement with the results obtained from the harmonic Hall method, confirming the exhibited large spin Hall effect of epitaxial SrIrO₃ thin films.

In summary, we reported a systematic investigation of spin–orbit coupling in epitaxial SrIrO₃ thin films. By measuring the harmonic Hall signals, a large spin-to-charge interconversion efficiency $|\theta_{\rm SH}|$ up to \sim 1.1 is determined at room temperature, which is further corroborated by ferromagnetic resonance-driven spin pumping measurements. Our results highlight the significant potential enabled by complex oxides in designing next-generation multifunctional spin-tronic devices for energy-favorable magnetic storage and logic devices.

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